`193414US2S



Hymdta Hoeel 4/26/or

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

Tatsuya KUNIKIYO

: GAU: 2814

SERIAL NO: 09/612,298

FILED: JULY 7, 2000

: EXAMINER: CAO, PHAT X.

FOR: SEMICONDUCTOR DEVICE

# **AMENDMENT**

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Responsive to the Office Action dated January 3, 2002, please amend the aboveidentified application as follows:

## IN THE TITLE

Page 1, line 2, delete in its entirety and substitute therefor:

## SEMICONDUCTOR DEVICE HAVING MULTILAYER

## INTERCONNECTION STRUCTURE

Please cancel Claims 2-6 and 16-20 without prejudice.

Please amend the claims as indicated in the marked-up copy to read as follows:

10. (Amended) A semiconductor device comprising:

a semiconductor substrate having a main surface along which a semiconductor element is formed;